FEB 23 2005
PATENT & TRADEMARK OFFICE

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(PTO-1449)

ATTY. DOCKET NO.	U.S. PATENT APPLICATION NO.
2336-233	10/734,151
APPLICANT: **Seuk Hwan CHUNG**	
FILING DATE: **December 15, 2003**	GROUP: **1722**

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation Yes	Translation No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

JH	**Patent Abstracts of Japan, Publication No. 02-096799, April 9, 1990**
JH	**Patent Abstracts of Japan, Publication No 2001-211499, August 3, 2001**

EXAMINER	/Jill Heitbrink/ (01/02/2007)	DATE CONSIDERED

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